

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) 17780		Application Number 10/849,285	
				Applicant(s) Shin-ichirou Ono, et al.			
				Filing Date May 19, 2004		Group Art Unit 2871	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,445,373 B1	9/3/02	Yamamoto			

U.S. PATENT APPLICATION PUBLICATIONS							
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FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		Hei 08-043816	2/16/96	Japan				✓
		2000-092415	3/31/00	Japan				✓
		2001-076529	3/23/01	Japan				✓

OTHER DOCUMENTS			(Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED
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